



**ELECTRONIC COPY**

LG659434084  
Report verification at igi.org



October 13, 2024

IGI Report Number **LG659434084**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **SQUARE EMERALD CUT**

Measurements **7.09 X 6.93 X 4.57 MM**

**GRADING RESULTS**

Carat Weight **2.09 CARATS**

Color Grade **D**

Clarity Grade **VVS 2**

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**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

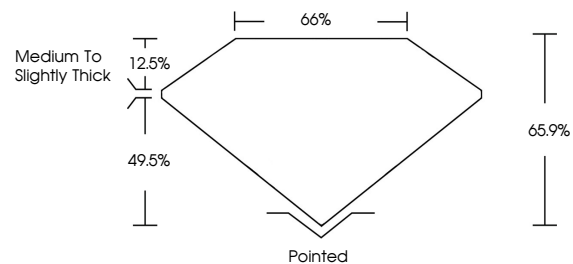
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG659434084**

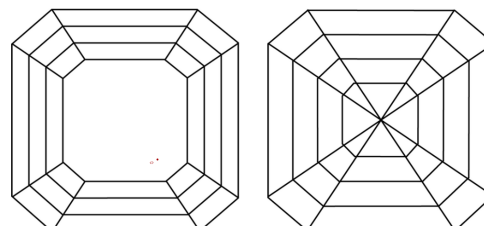
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

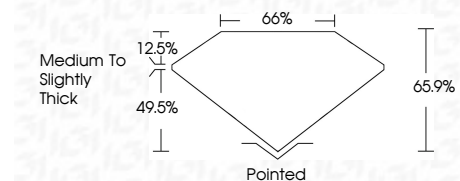
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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Symmetry **EXCELLENT**

Fluorescence **NONE**

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**IGI**



October 13, 2024  
IGI Report No **LG659434084**  
**SQUARE EMERALD CUT**  
7.09 X 6.93 X 4.57 MM  
Carat Weight **2.09 CARATS**  
Color Grade **D**  
Clarity Grade **VVS 2**  
Depth **65.9%**  
Table **66%**  
Girdle **Medium to Slightly Thick**  
Culet **Pointed**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG659434084**  
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